

Multiscale Simulation for Electronic Devices Innovation

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Introduction

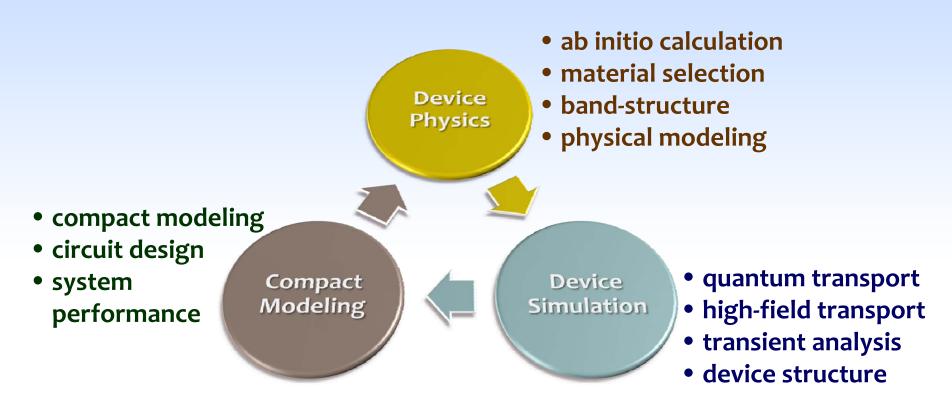
- Computer-aided design (CAD) tools are widely used for modeling and simulation of semiconductor electronic devices.
- To optimize system performance, technology CAD tools should cover circuit design as well as material selection.



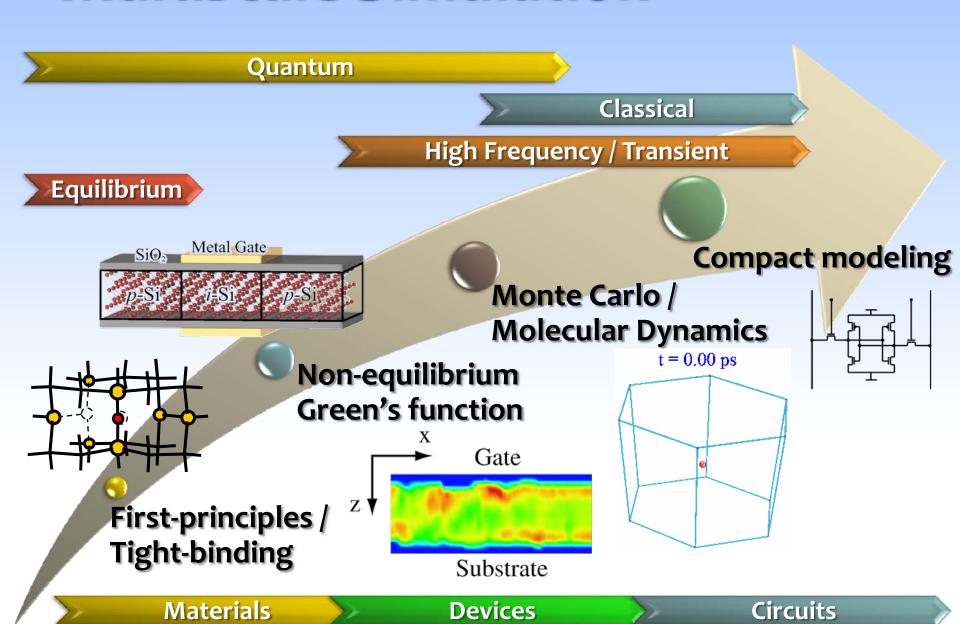
Multiscale simulation techniques, which span the entire length scale from the atomistic to circuit level

Objective

A primary goal of our project is the seamless integration of hierarchies from the atomistic approach to compact modeling.



Multiscale Simulation



Summary

- Our unit focuses on simulation technologies for next-generation high power/ultrafast devices.
- A primary goal of the project is to develop and integrate the following four technologies:
 - band-structure calculation/material selection technology based on the first-principles method
 - transient response modeling technology
 - high-field transport simulation technology
 - compact modeling technology